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MAY 12 2005

Docket No.: 100718.124 (MIC-58DV2)

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :

Tianhong Zhang, et al. :

Serial No. 09/722,400 :

Group Art Unit: 1756

Filed: November 27, 2000 :

Examiner: Mohamedulla, Saleha R.

For: POLYIMIDE AS A MASK IN VAPOR HYDROGEN FLUORIDE ETCHING

PETITION FOR EXTENSION OF TIME

Honorable Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

Applicant petitions the Commissioner for Patents to extend the time for response to the Office Action dated November 12, 2004, 2004, for three months, from February 12, 2004 to May 12, 2005.

Please charge the \$1020.00 fee to cover the cost of the extensions to Deposit Account No. 08-0219. Any deficiency or overpayment should be charged or credited to Deposit Account No. 08-0219.

Respectfully submitted,

Wilmer Cutler Pickering Hale and Dorr LLP



Leonid D. Thenor
Registration No. 39,397

The Willard Office Building
1455 Pennsylvania Avenue, NW
Washington, DC 20004
202 942 8400
Date: May 12, 2005

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